

**Amendments to the Specification:**

Please replace the Title with the following amended Title:

METHOD FOR FORMING A SEMICONDUCTOR STRUCTURE WITH IMPROVED  
SMALLER FORWARD VOLTAGE LOSS AND HIGHER BLOCKING CAPABILITY

Please add the following new Heading and paragraph after the Title on page 1:

**CROSS-REFERENCE TO RELATED APPLICATIONS**

This application is a divisional of and claims priority to U.S. Application No. 09/981,583, filed October 17, 2001, entitled "Semiconductor Structure with Improved Smaller Forward Voltage Loss and Higher Blocking Capability", which disclosure is incorporated herein by reference.